

Docket No.: 50099-184

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

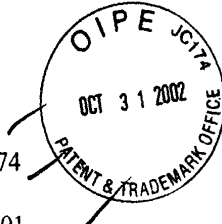
In re Application of

Masato FUJINAGA

Serial No.: 09/977,274

Filed: October 16, 2001

For: HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME



Group Art Unit: 2826

Examiner: Leonardo Andujar

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RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
Washington, DC 20231

Sir:

Noting the Office Action of October 2, 2002 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-8) for prosecution in the above-identified application. Rejoinder of the non-elected method claims upon allowance of counterpart elected claims is requested.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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**Date: October 31, 2002**